Annication Number	1,0	10670					
Application Number:	100	10649670					
Filing Date:	28-	28-Aug-2003					
Title of Invention:	PL	PLASMA PROCESSING METHOD AND APPARATUS					
First Named Inventor/Applicant Name:	Mit	Mitsuo Saitoh					
Filer:	Mie	Michael S. Huppert/Kelly Fore					
Attorney Docket Number:	200	2003_1228A					
Filed as Large Entity	•						
Utility under 35 USC 111(a) Filing Fees	i						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1810